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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/710,841	08/06/2004	Masuhiro Natsuhara	39.053	4840	
29453 75	7590 10/23/2006 EXAMINER				
JUDGE & MURAKAMI IP ASSOCIATES DOJIMIA BUILDING, 7TH FLOOR			KACKAR	KACKAR, RAM N	
6-8 NISHITEMMA 2-CHOME, KITA-KU		-KU	ART UNIT	PAPER NUMBER	
OSAKA-SHI,	•				
JAPAN			DATE MAILED: 10/23/200	DATE MAILED: 10/23/2006	

Please find below and/or attached an Office communication concerning this application or proceeding.

•		Application No.	Applicant(s)		
		10/710,841	NATSUHARA ET AL.		
	Office Action Summary	Examiner	Art Unit		
		Ram N. Kackar	1763		
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply					
A SH WHIC - Exte after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REPLY CHEVER IS LONGER, FROM THE MAILING DON'S INTERPRETABLE OF THE MAILING DEPLY WILLIAM THE MAILING	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be timused and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	N. nely filed the mailing date of this communication. D (35 U.S.C. § 133).		
Status			,		
2a) <u></u>	·—	action is non-final.			
Dispositi	ion of Claims				
5)□ 6)⊠ 7)□ 8)□	Claim(s) 1-5 is/are pending in the application.  4a) Of the above claim(s) is/are withdraw Claim(s) is/are allowed.  Claim(s) 1-5 is/are rejected.  Claim(s) is/are objected to.  Claim(s) are subject to restriction and/or ion Papers				
10)	The specification is objected to by the Examine The drawing(s) filed on is/are: a) accomplicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Examine	epted or b) objected to by the Edrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).		
Priority ι	under 35 U.S.C. § 119				
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).  a) □ All b) □ Some * c) □ None of:  1. □ Certified copies of the priority documents have been received.  2. □ Certified copies of the priority documents have been received in Application No  3. □ Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).  * See the attached detailed Office action for a list of the certified copies not received.					
Attachmen	• •				
2)	e of References Cited (PTO-892) se of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO/SB/08) r No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	te		

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## DETAILED ACTION

## Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

2. Claims 1-5 are rejected under 35 U.S.C. 102(b) as being anticipated by Tamura et al (US 5792304).

Tamura et al disclose a semiconductor processing device comprising a wafer holder to hold and transport substrates (Fig 13-2 and Col 17-line 29- line 37), a vertically movable pedestal (63 and Col 17-line 53 to Col 18 line 4), support pieces mounted to pedestal (Fig 9 and Fig 13), a hermetic bellows seal between pedestal and chamber (50) and lift pins to load /unload substrates (19).

3. Claims 1-5 are rejected under 35 U.S.C. 102(b) as being anticipated by Aruga et al (US 5688331).

Aruga et al disclose a semiconductor processing device comprising a wafer holder to hold and transport substrates (Fig 6-39), a vertically movable pedestal (95 and 61), support pieces mounted to pedestal (Fig 6), a hermetic bellows seal between pedestal and chamber (37) and lift pins to load /unload substrates (Col 5 lines 15-20 and Col 11 lines 62-68).

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4. Claims 1-5 are rejected under 35 U.S.C. 102(e) as being anticipated by Brown et al (US 20030029568).

Brown et al disclose a semiconductor processing device comprising a wafer holder to hold and transport substrates (Fig 2 and Paragraphs 39-42), a vertically movable pedestal, support pieces mounted to pedestal (Fig 2), a hermetic bellows seal between pedestal and chamber (252) and lift pins to load /unload substrates (290).

## Conclusion

5. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Wafer holder to hold and transport substrates with vertically movable pedestal, a hermetic bellows seal between pedestal and chamber and lift pins to load /unload substrates are also disclosed by Schieve et al (2004/0177813), Yudovsky et al (2003/0136520) and others.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ram N. Kackar whose telephone number is 571 272 1436. The examiner can normally be reached on M-F 8:00 A.M to 5:P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on 571 272 1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would

like assistance from a USPTO Customer Service Representative or access to the automated

information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Ram Kackar

Primary Examiner AU 1763